



ELG Docket No. ILL02-023-DIV-US

JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named Inventor: Chang Liu Examiner: James L. Leybourne
Serial No.: 10/670,585
Filing Date: September 25, 2003 Group Art Unit: 2881
Title: SCANNING PROBE MICROSCOPY
PROBES AND METHODS

TRANSMITTAL AND CERTIFICATE OF MAILING UNDER 37 CFR 1.8

I certify that the following correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

M.S. – Amendment
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on

May 25, 2005
Date

Jonathan M. Blanchard, Ph.D. Registration No. 48,927

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3. Form PTO 1449
4. References C1-C2

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566 West Adams
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ILL02-023-DIV-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Chang Liu, et al.)
Serial No. 10/670,585) Examiner James J. Leybourne
Filing Date: September 25, 2003) Group Art Unit No. 2881
For SCANNING PROBE MICROSCOPY)
PROBES AND METHODS)

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. § 1.56, Applicants request that citation and examination of the references identified on the attached PTO-1449 form, required copies of which are enclosed herewith in accordance with 37 C.F.R. §1.98, be made during the course of examination of the above-referenced application for United States Letters Patent.

Since this Information Disclosure Statement is being submitted after the mailing of the first Office Action, payment of the fee set forth in 37C.F.R. §1.17(p) accompanies this submission. The Commissioner is hereby authorized to charge any fees associated with this communication not covered by check or credit card payment or credit any overpayment to Deposit Account No. 50-3123. A duplicate copy of this sheet is attached.

Respectfully submitted,



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Form PTO-1449 (Rev. 8-88)	Attorney Docket No. ILL02-023-DIV-US	Serial No. 10/670,585
Applicant: Chang Liu, et al.		
INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)	Filing Date: September 25, 2003	Group: 2881

Examiner Initials*		OTHER ITEMS - NON PATENT LITERATURE DOCUMENTS Include, as applicable: Author, Title, Date, Publisher, Edition or Volume, Pertinent Pages
	C1	Niklaus, F., "Void-Free Full Wafer Adhesive Bonding", presented at MEMS'00, Miyazaci, Japan, Jan. 23-27, 2000, pp. 323-328, Miyazaki, Japan.
	C2	Pierret, Robert F., Semiconductor Device Fundamentals, Table 1.1, (1995), Addison-Wesley, page 4.

Examiner	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



Case No. ILL02-023-DIV-US
Applicant: Chang Liu, et al.
Serial No. 10/670,585
Filing Date: September 25, 2003
For: SCANNING PROBE MICROSCOPY PROBES AND METHODS

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Transmitted herewith is:

- Transmittal and Certificate of Mailing (in duplicate)
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- Information Disclosure Statement
- Form PTO 1449
- References C1-C2

Jonathan M. Blanchard, Ph.D., Registration No. 48,927

Date of Mailing May 25, 2005